Attorney's Docket No.: 10417-119001 / F51-143213M/SW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Yoshinori Hino et al.

Art Unit: 2811

Serial No.: 10/080,831

Examiner: J. Nguyen

Filed

: February 21, 2002

Title

: SEMICONDUCTOR DEVICE AND PATTERN LAYOUT METHOD THEREOF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF AUGUST 20, 2003

Please amend the above-identified application as follows:

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

PATRICIA F. SUCHANEK

Typed or Printed Name of Person Signing Certificate